Appln. No.: 09/783,023

Amendment dated August 21, 2003

Reply to Office Action of June 11, 2003

This listing of claims will replace all prior versions, and listings, of claims in the application:

**Listing of Claims:** 

Claim 1 (currently amended): A semiconductor device, comprising:

a first concave portion for element isolation, formed in a semiconductor substrate;

a second concave portion formed in the semiconductor substrate and having a depth from

a top surface of the semiconductor substrate, substantially equal to a depth of the first concave

portion;

a first gate insulating film formed on a selected portion of said semiconductor substrate;

a second gate insulating film formed in at least a bottom surface of said second concave

portion;

a first conductive film formed on said first gate insulating film; and

a second conductive film formed on said second gate insulating film.

Claim 2 (previously presented): The semiconductor device according to claim 1, wherein the

second gate insulating film and the second conductive film are formed on the bottom surface of

the second concave portion, on at least one side surface of the second concave portion and on the

semiconductor substrate, and a top surface of the first conductive film is flush with a surface of

the second conductive film formed on the semiconductor substrate.

Claim 3 (previously presented): The semiconductor device according to claim 1, wherein the

second gate insulating film is formed in a corner portion of the second concave portion.

Claim 4 (previously presented): The semiconductor device according to claim 1, wherein an

insulating film is formed on the second conductive film, and the second concave portion is filled

with the insulating film, the second gate insulating film and the second conductive film.

Claim 5 (previously presented): The semiconductor device according to claim 1, wherein the

second concave portion is filled with the second gate insulating film and the second conductive

film, and a surface of the second conductive film is substantially flat.

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Claim 6 (original): The semiconductor device according to claim 1, wherein the semiconductor

substrate is an SOI substrate.

Claim 7 (previously presented): The semiconductor device according to claim 1, further

comprising:

an element isolating region formed within the first concave portion such that the second

gate insulating film and the second conductive film are allowed to extend over said element

isolating region;

a contact electrically connected to a portion of the second conductive film which is

positioned on the element isolating region; and

a wiring electrically connected to said contact.

Claim 8 (previously presented): The semiconductor device according to claim 1, wherein a

plurality of second concave portions are formed in the semiconductor substrate such that the

second concave portions are filled with the second gate insulating film and the second

conductive film, and a surface of the second conductive film is substantially flat.

Claim 9 (previously presented): The semiconductor device according to claim 1, wherein a

plurality of gate electrodes each consisting of the second conductive film is formed in said

second concave portions.

Claim 10 (previously presented): The semiconductor device according to claim 1, wherein an

impurity concentration in the second conductive film is higher than an impurity concentration in

the semiconductor substrate.

Claim 11 (previously presented): The semiconductor device according to claim 1, wherein said

second insulating film functions as an insulating film for an anti-fuse portion or for a capacitor

element.

Claims 12-20 (canceled)

Claims 21-31 (withdrawn)

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